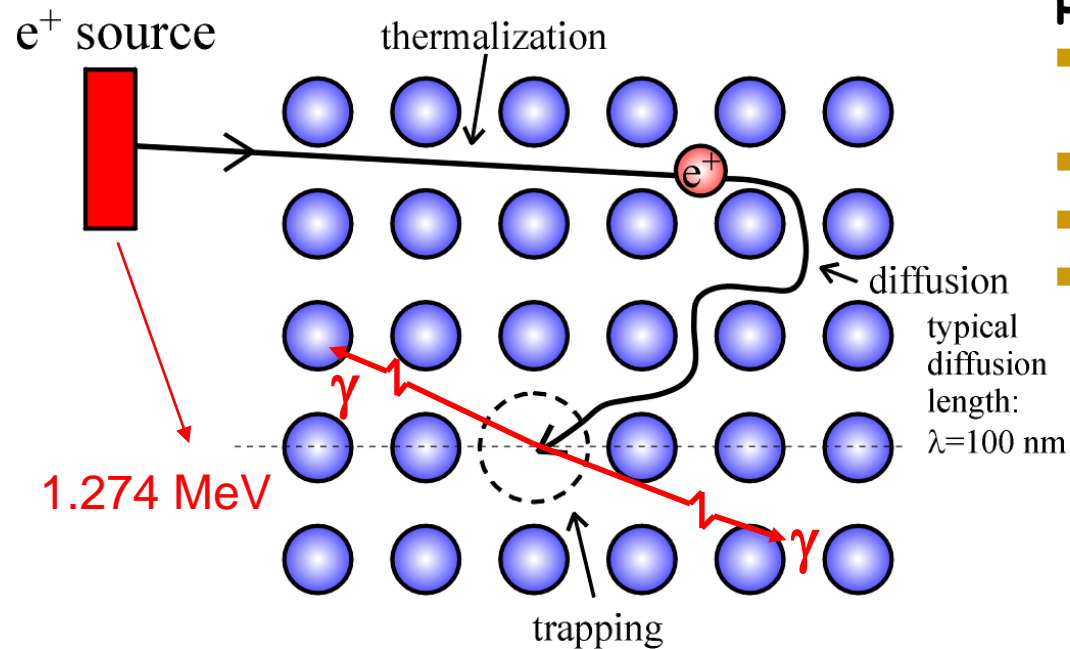
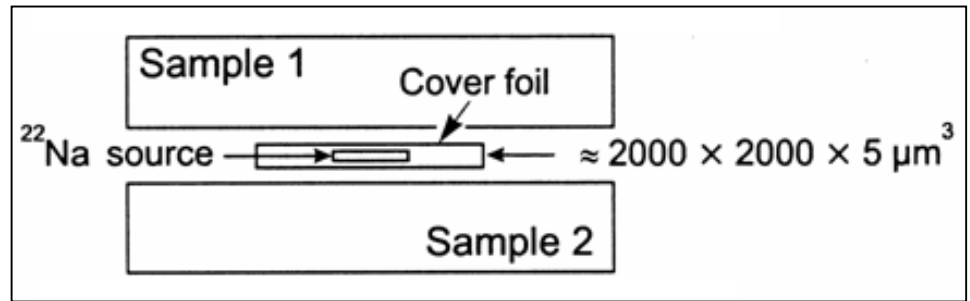
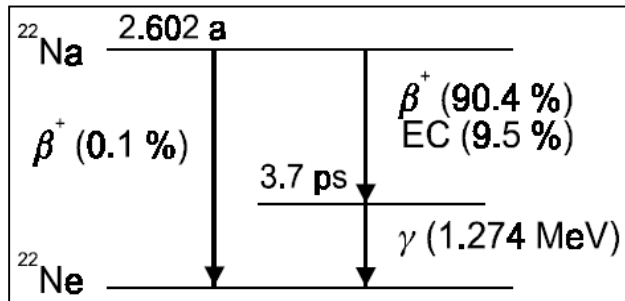


Positron Annihilation Spectroscopy Measurements for Porosimetry

R. Krause-Rehberg, Dept. of Physics, University Halle



Positron Annihilation Lifetime Spectroscopy - PALS



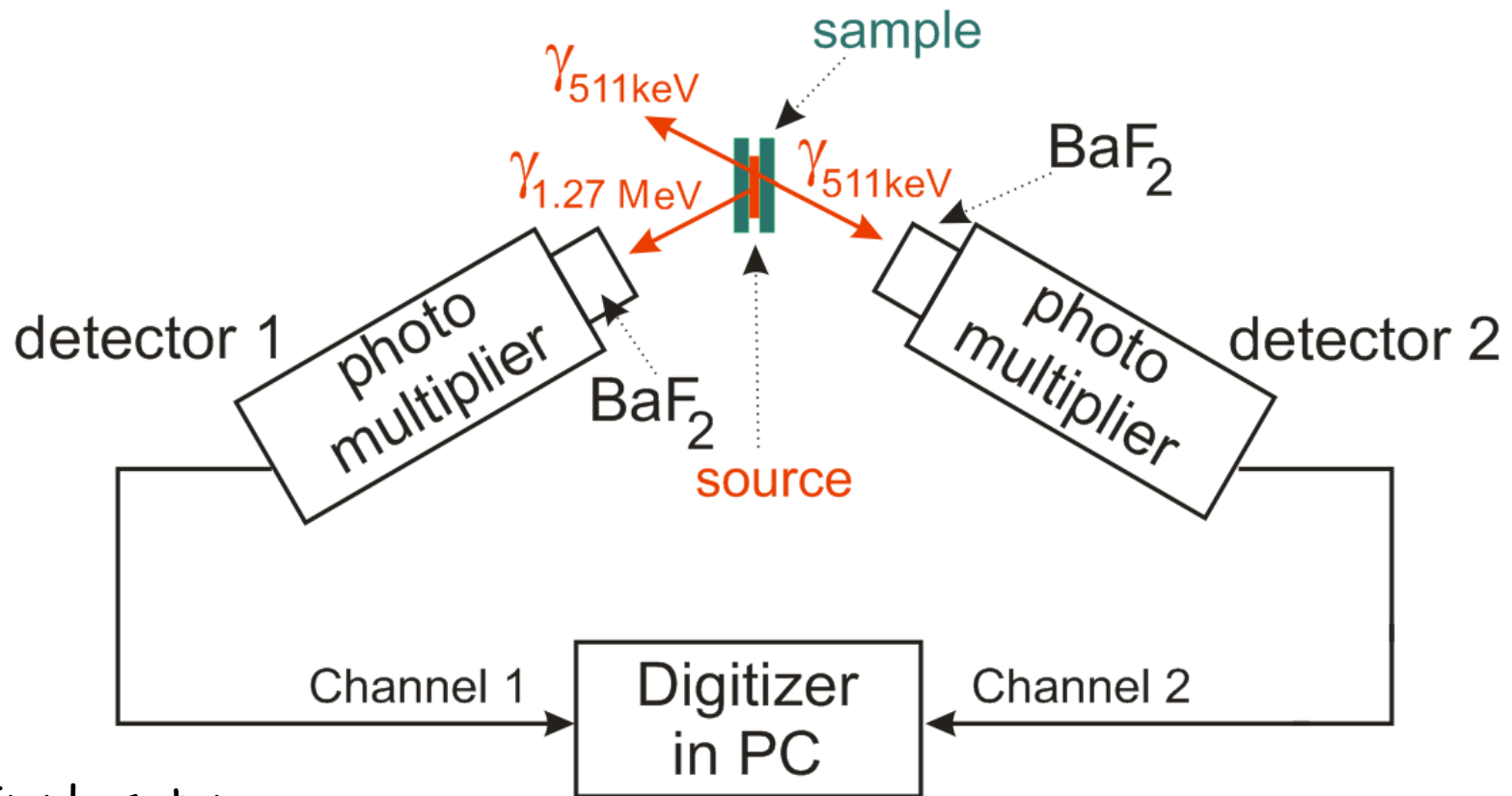
positrons:

- thermalize (reach thermal energies)
- diffuse
- being trapped
- and annihilate

When trapped in vacancies:

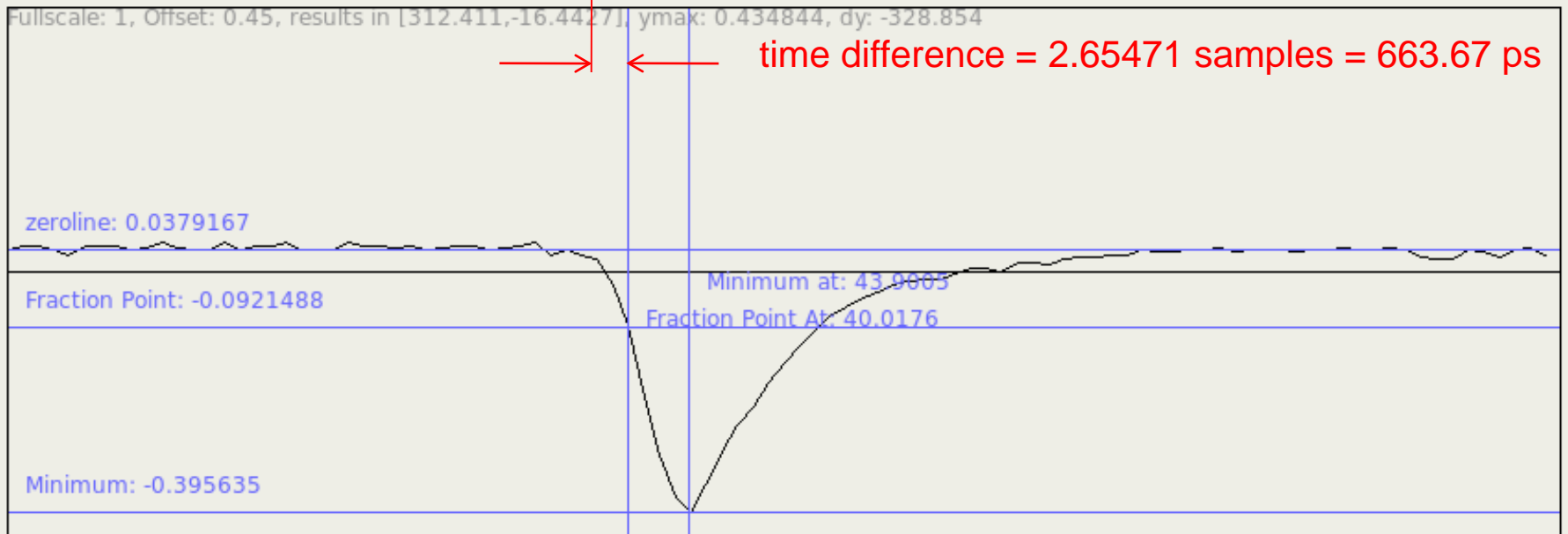
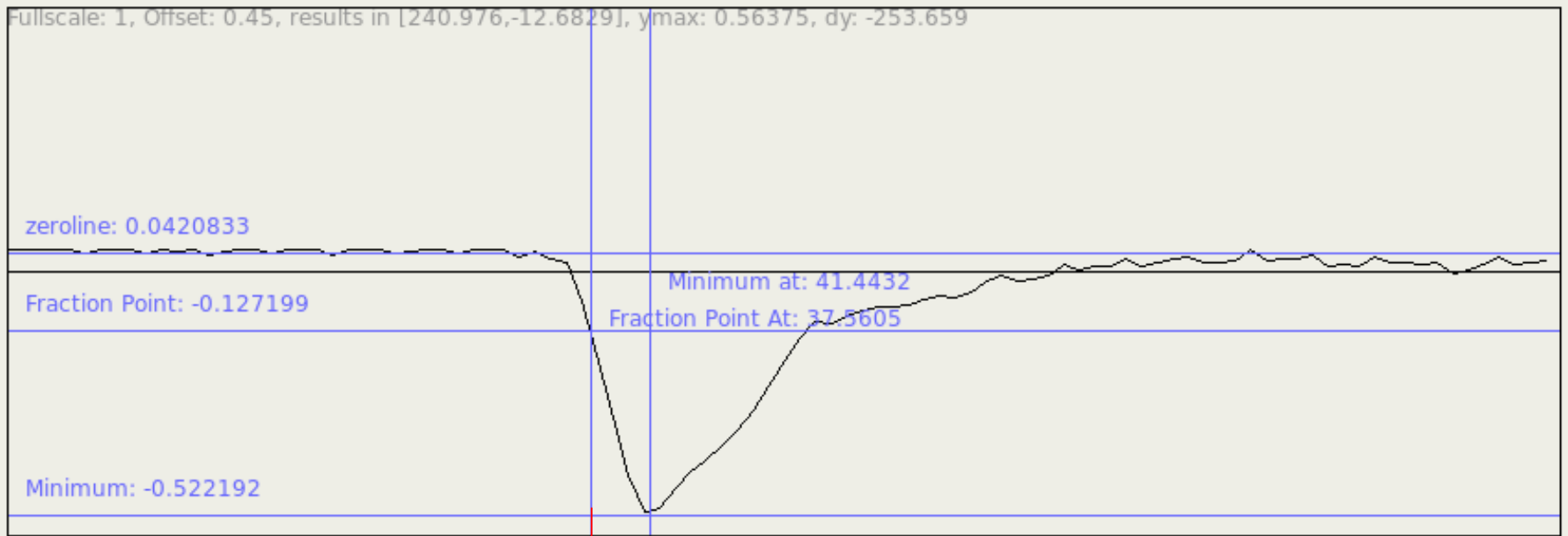
- Lifetime increases due to smaller electron density in open volume

Digital lifetime measurement

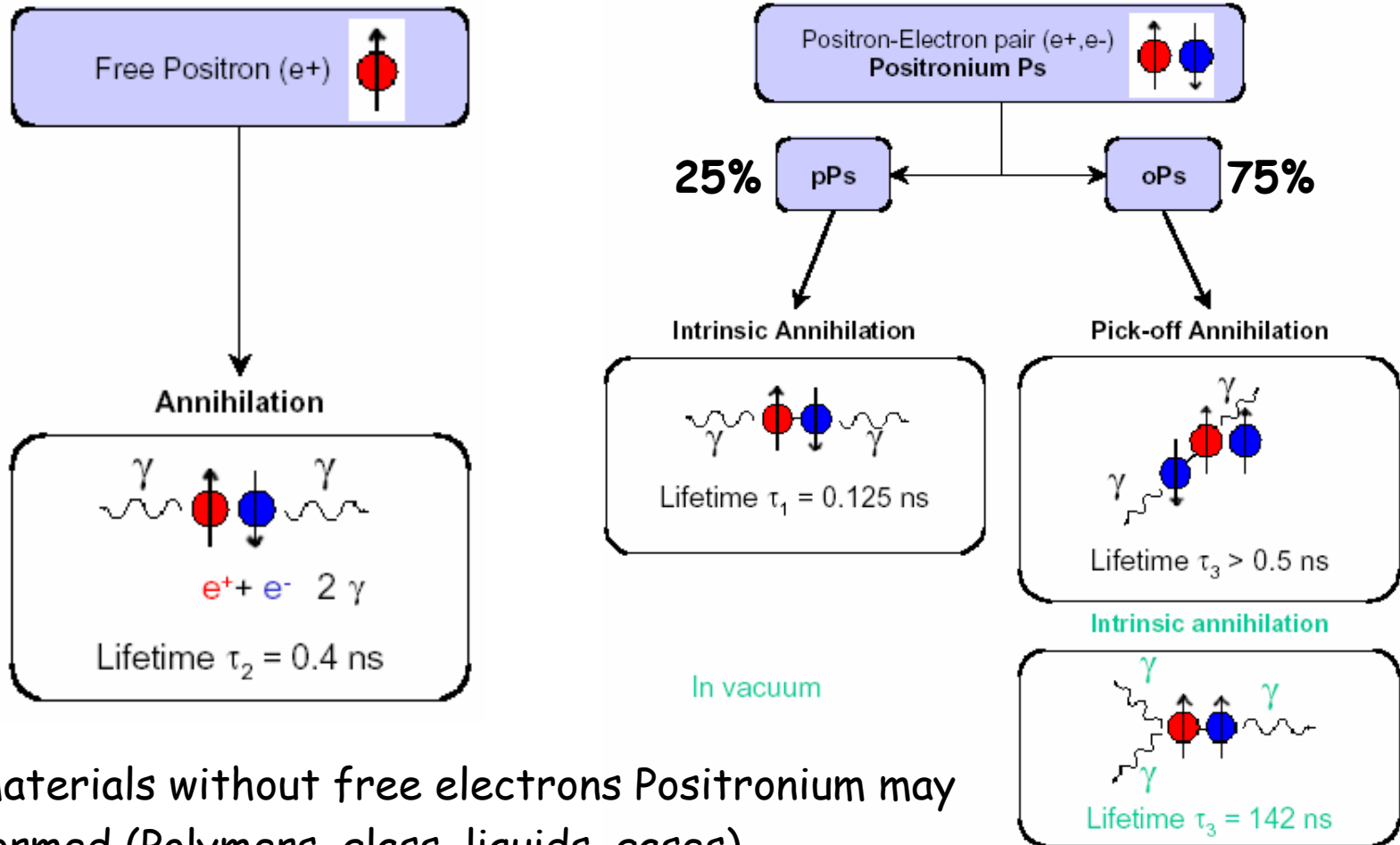


- simple setup
- timing very accurate
- each detector for start & stop (double statistics)

Screenshot of two digitized anode pulses

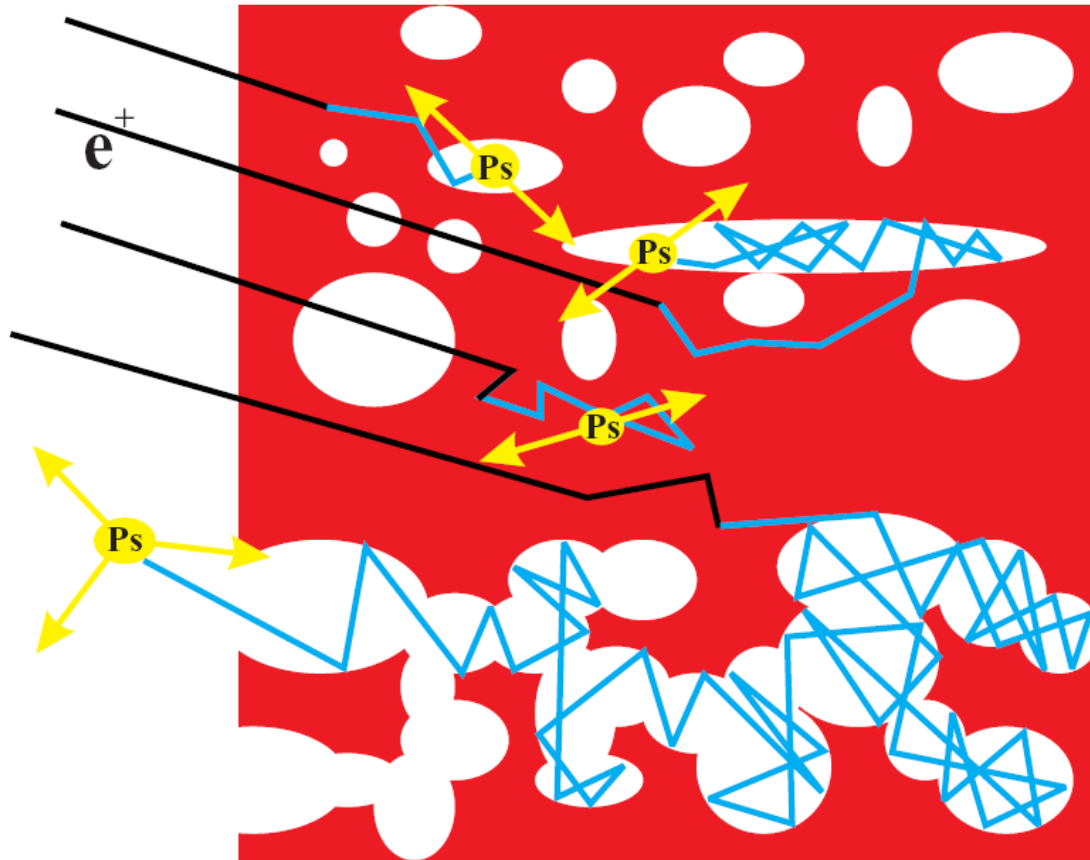


Principles of PALS: ortho-Positronium



- In materials without free electrons Positronium may be formed (Polymers, glass, liquids, gases).

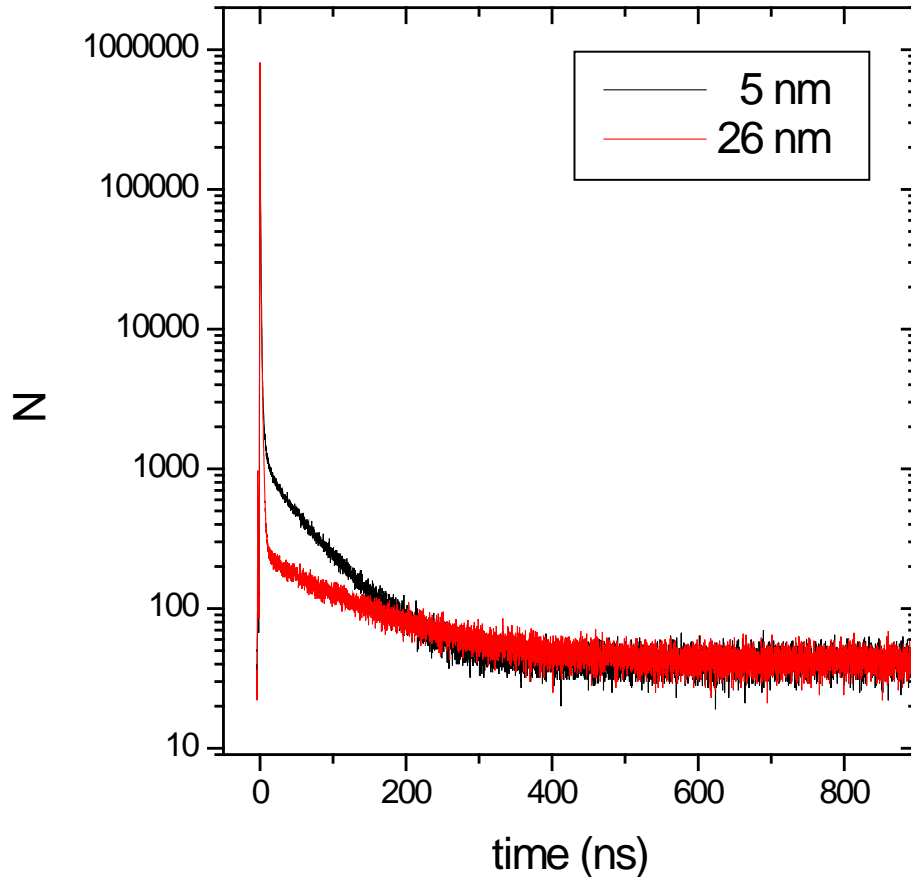
Principles of PALS: pick-off Annihilation



pick-off annihilation:

- o-Ps is converted to p-Ps by capturing an electron with anti-parallel spin
- happens during collisions at walls of pore
- lifetime decreases rapidly
- lifetime is function of pore size 0.5 ns ... 142 ns
- lifetime can be extracted from spectra

Principles of PALS: typical spectrum

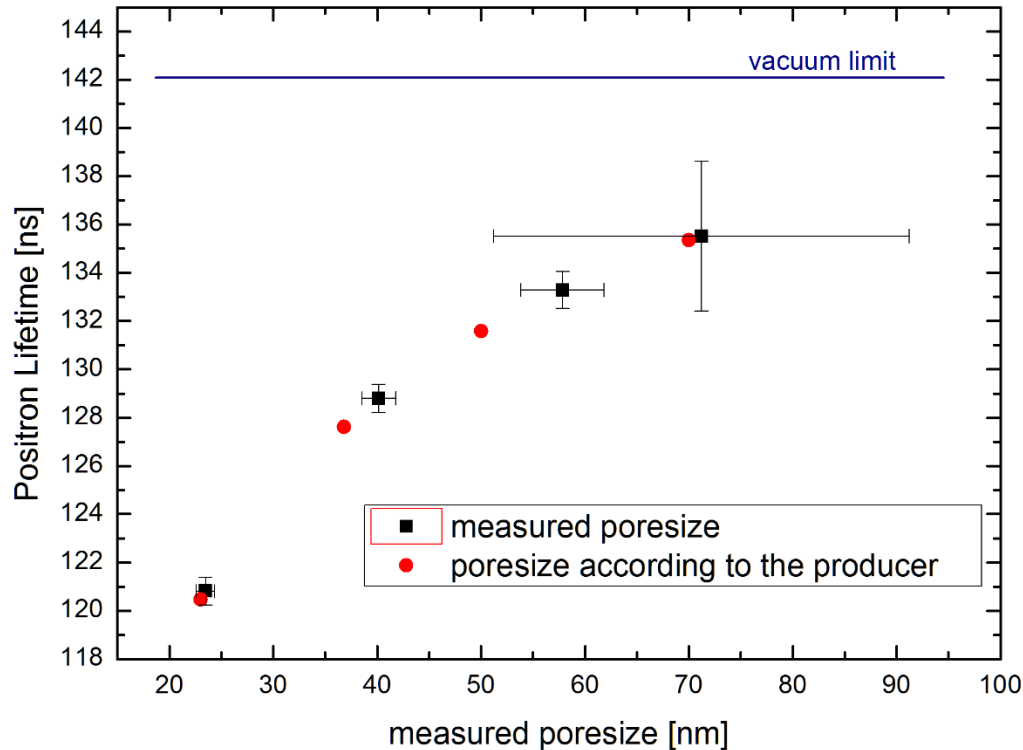


typical lifetime spectrum
for porous glass:

- 4 exponential decay components
- p-Ps \rightarrow 0.125 ns
- free positrons \sim 0.5 ns
- o-Ps in amorphous region of glass \sim 1.5 ns
- o-Ps in pores

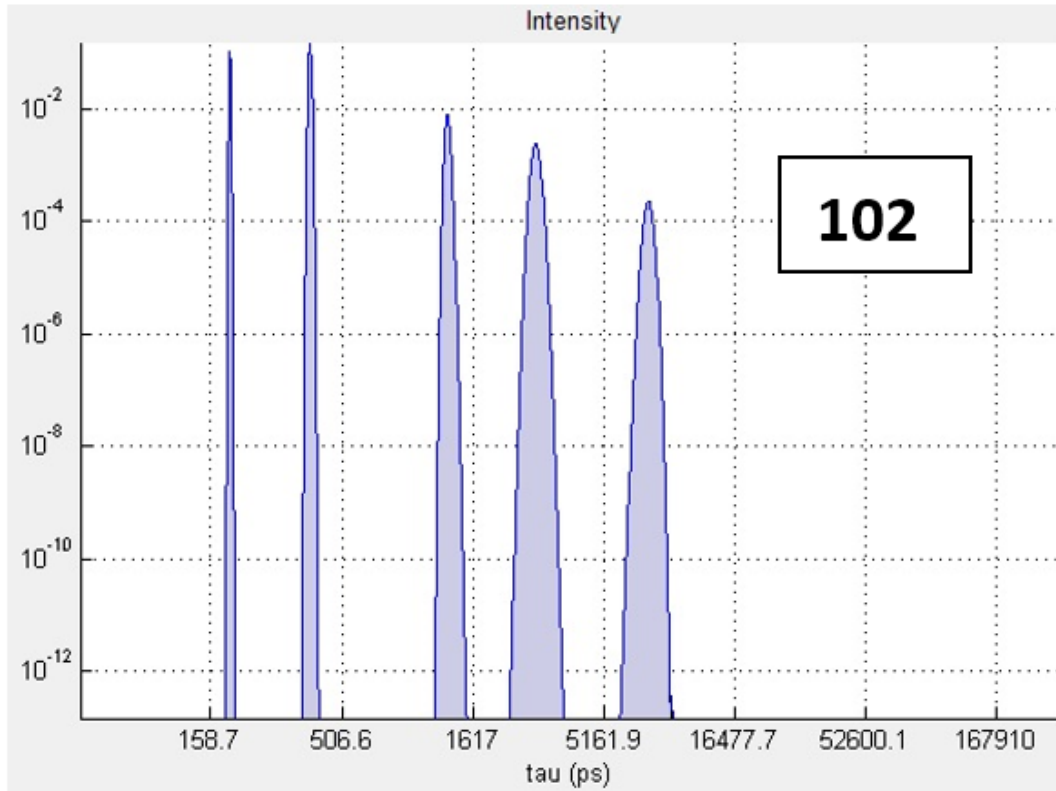
$$N(t) = \sum_{i=1}^{k+1} \frac{I_i}{\tau_i} \exp\left(-\frac{t}{\tau_i}\right)$$

PALS: detection limits



- lower detection limit: open volume of 2 Å diameter
- e.g. open volume between polymer chains
- upper limit: ≈ 60 nm diameter
- physical limit: vacuum lifetime of o-Ps = 142 ns
- upper limit depends also on corresponding intensity

New Analysis Technique: MELT



porous polymer

**MELT¹ = Maximum Entropy
for Lifetime Analysis**

- number of components must not be known
- output is intensity versus lifetime
- pore size distribution can be determined
- disadvantage: very high statistics necessary ($> 10^7$ counts)

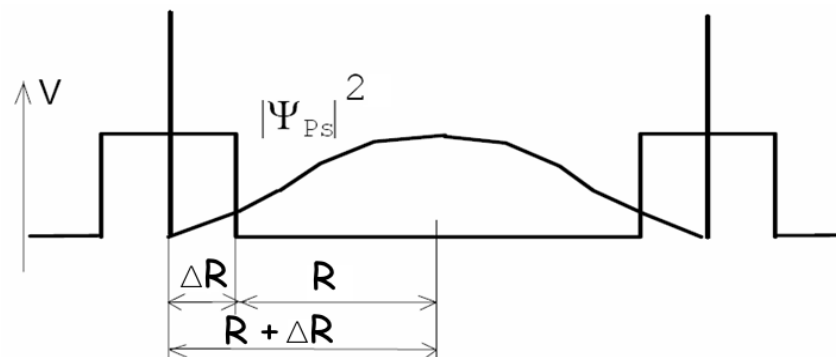
The TE model

- Annihilation rate: $\frac{1}{\tau_{o-Ps}} = \lambda_{o-Ps}$

$$= \lambda_{2\gamma} + \lambda_{3\gamma}$$

$$= \lambda_{2\gamma}^0(P) + \lambda_{3\gamma}^0(1-P) \cong \lambda_{2\gamma}^0(P)$$

$$\lambda_{2\gamma}^0 = \frac{\lambda_S + 3\lambda_T}{4} = \lambda_A \approx 2ns^{-1}$$

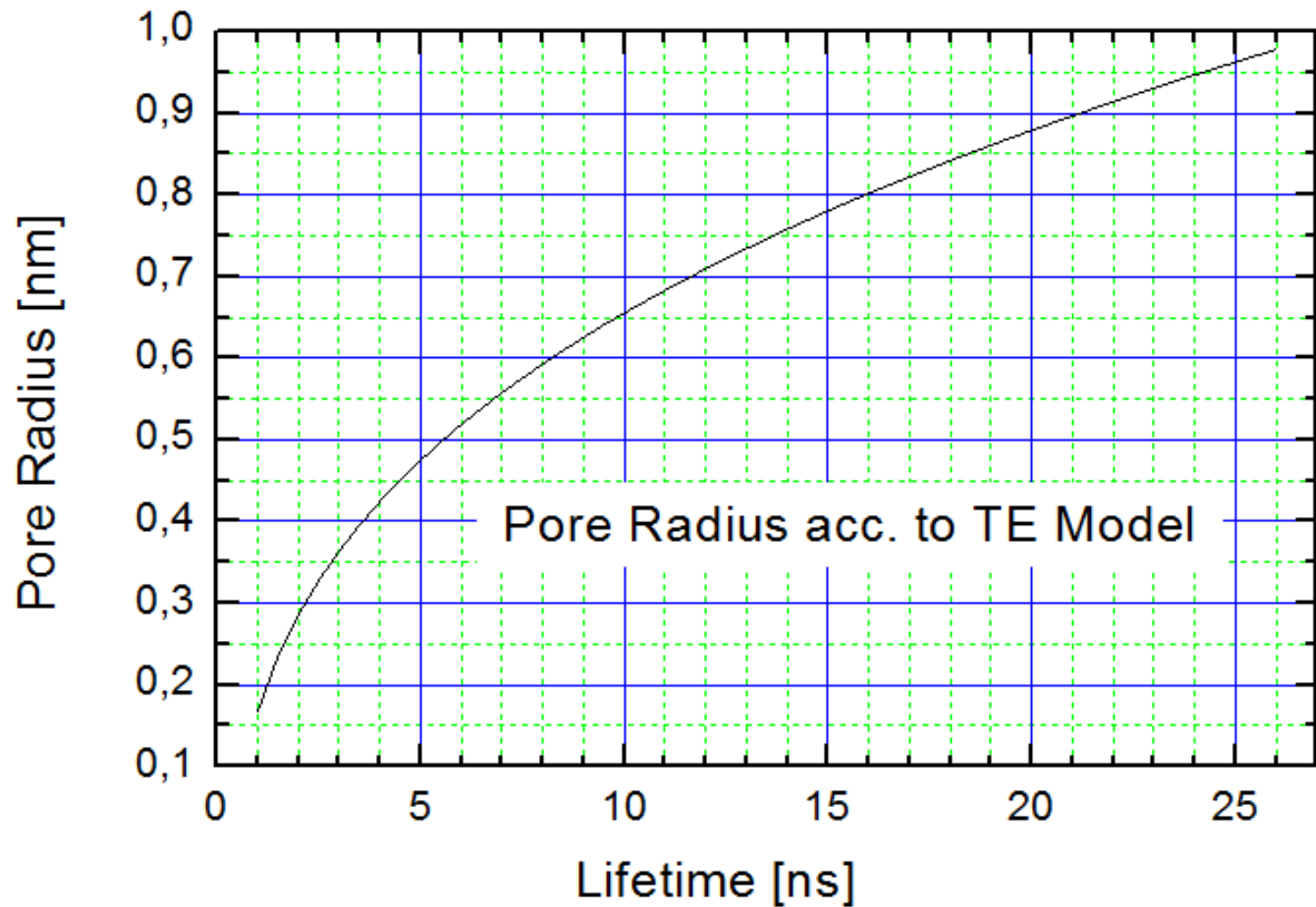


- Pore size < 1 nm → $\lambda_{3\gamma}$ neglected, only pick off annihilation

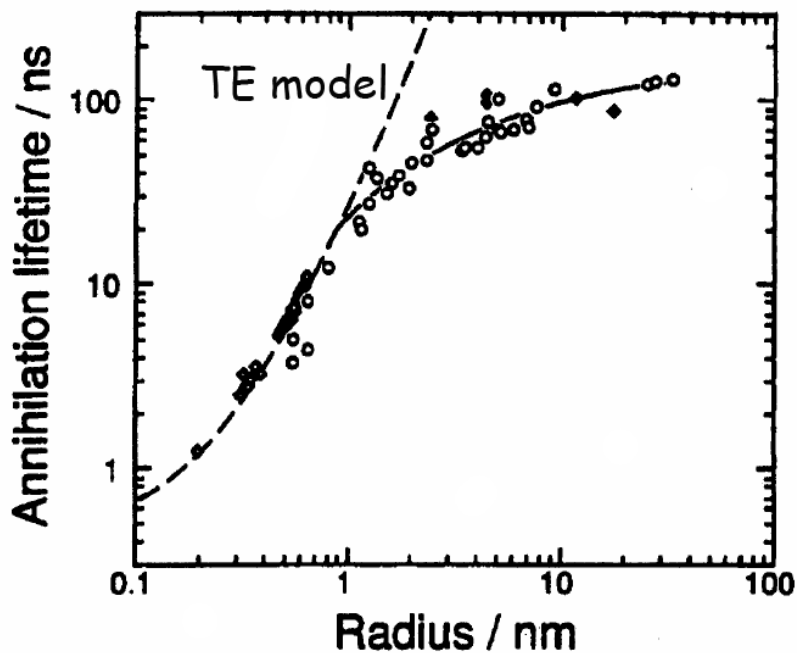
$$\lambda_{TE}(R) = \lambda_A \left[1 - \frac{R}{R + \Delta R} + \frac{1}{2\pi} \sin\left(\frac{2\pi R}{R + \Delta R}\right) \right]$$

- $\Delta R = 0.166$ nm determined by Eldrup and Jean
- Pore size > 1 nm → $\lambda_{3\gamma}$ cannot be neglected, temperature dependence of o-Ps lifetime (excited states)

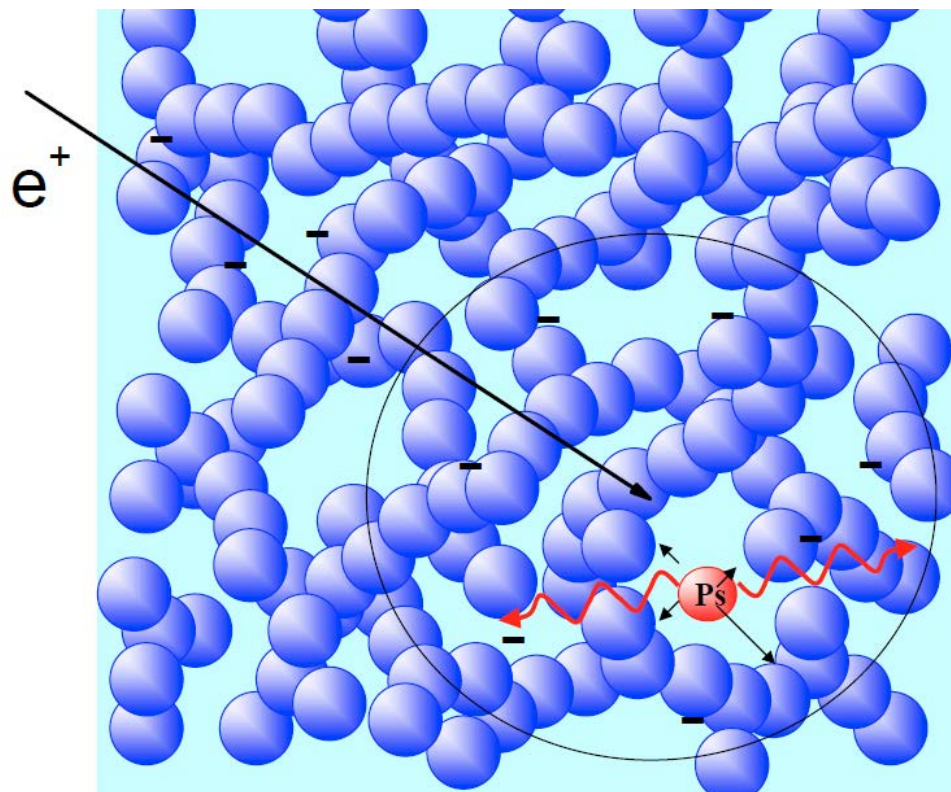
The TE model (valid until 1 nm radius)



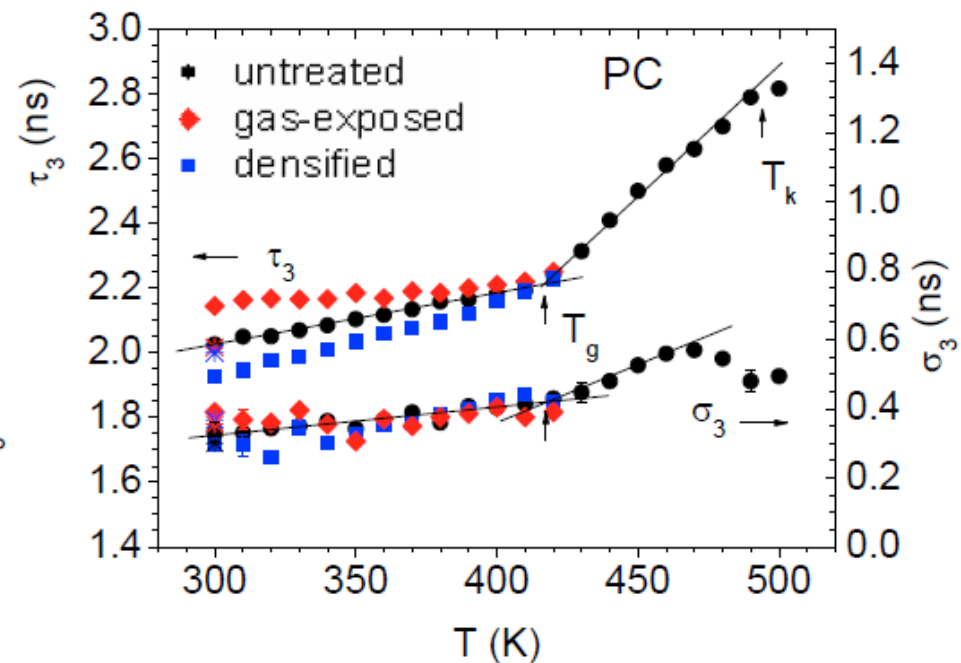
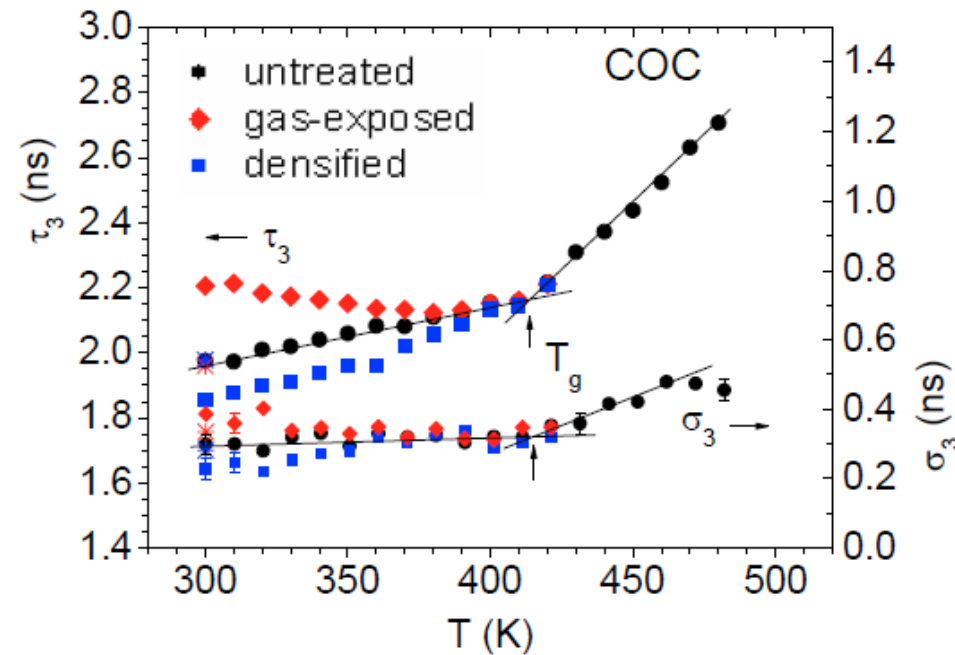
The TE model



- TE model valid for $r > 2\text{nm}$
- very successful for open-volume characterization in polymers



Polymer research



PALS study of different polymers under CO₂ gas exposure and pressure densified (200 MPa)

Polymer research

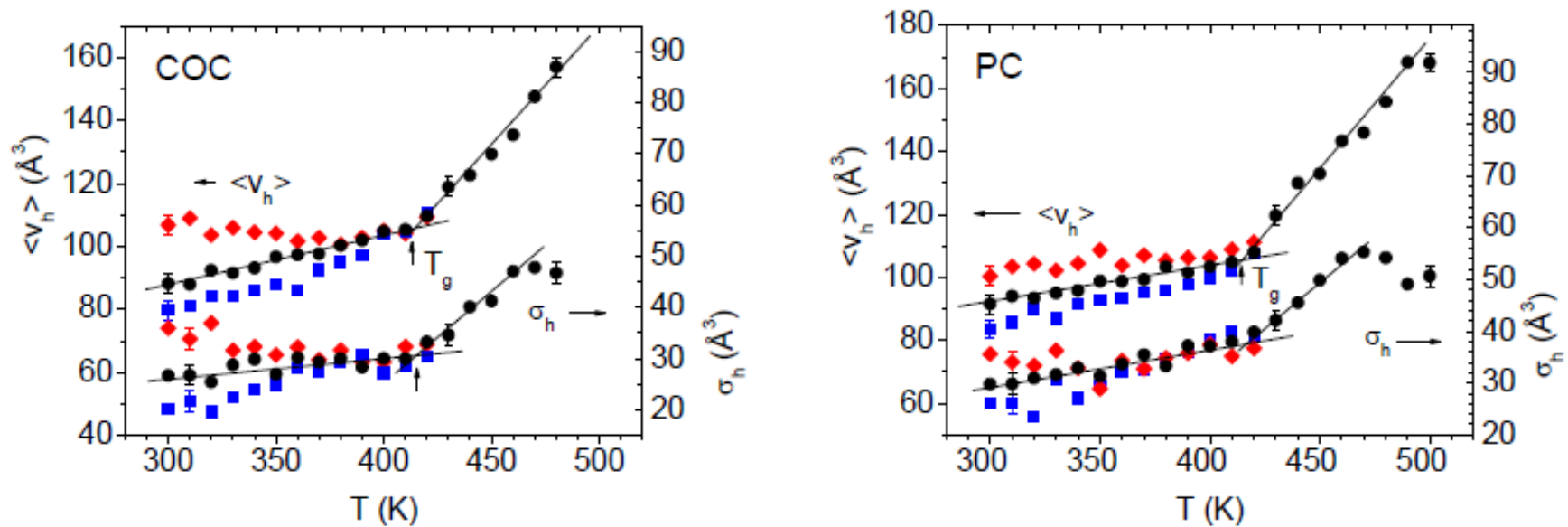
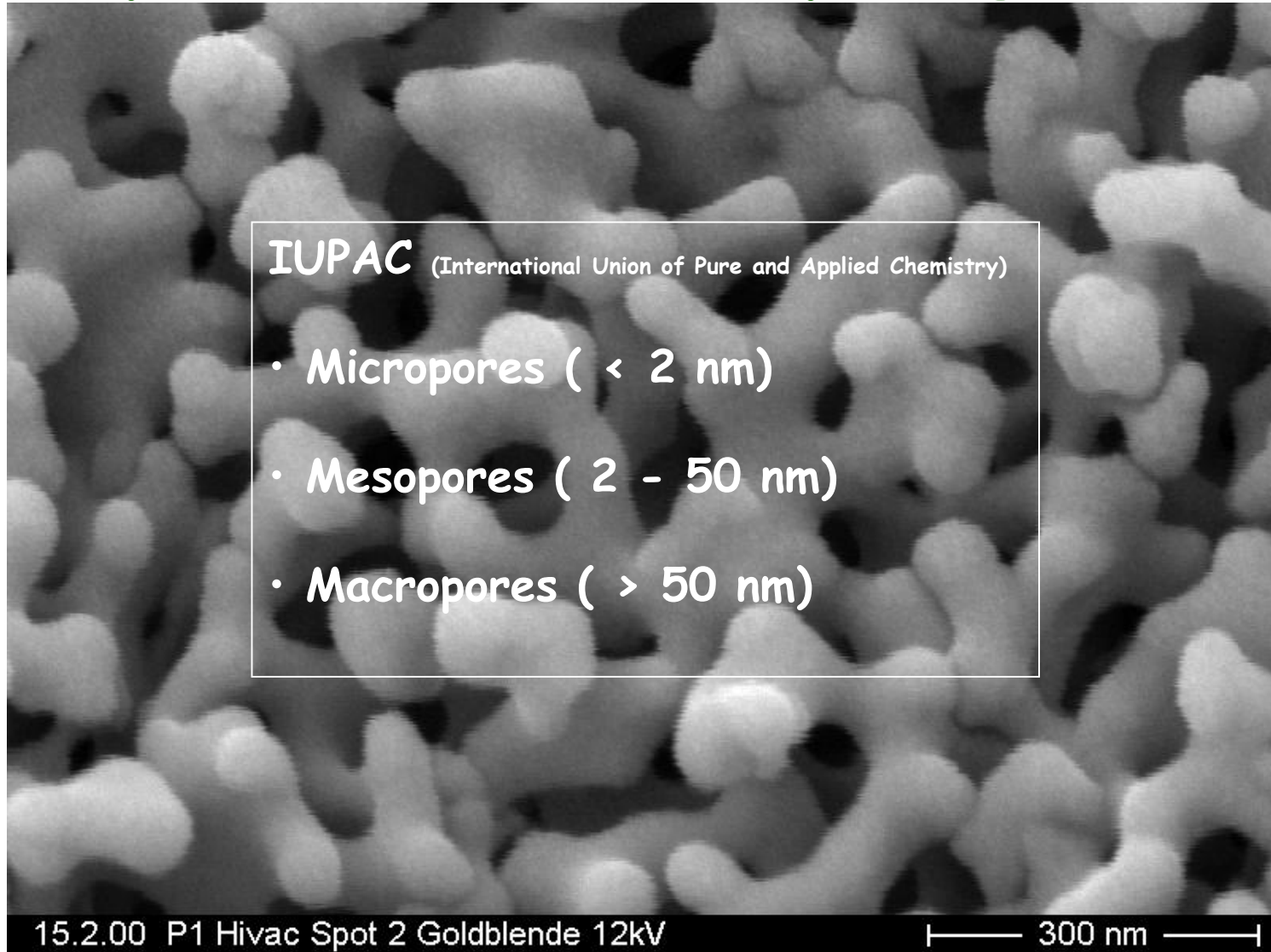
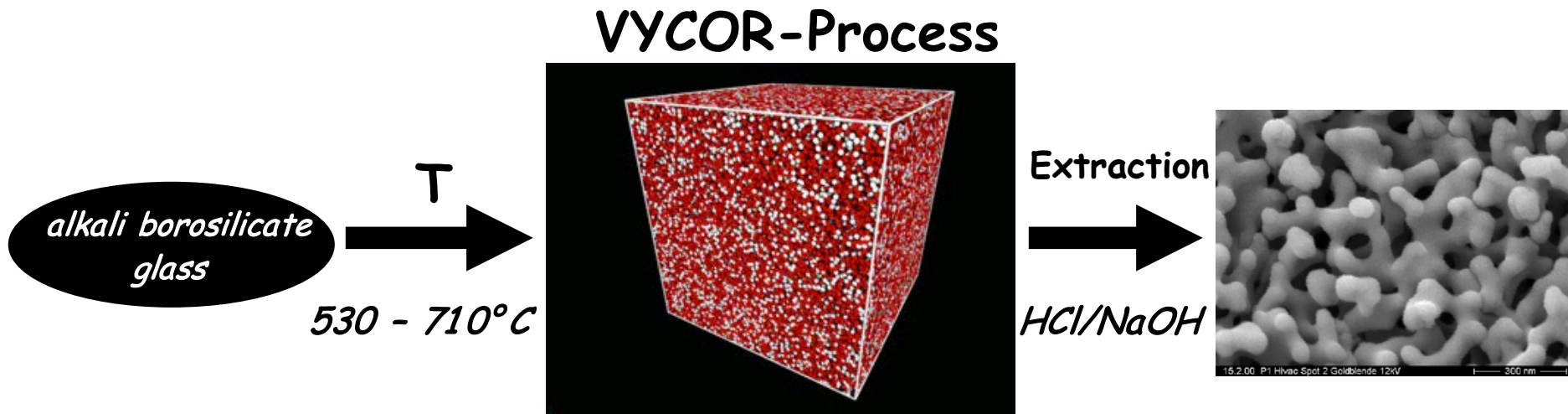


Fig. 5. The mean, $\langle v_h \rangle$, and the mean dispersion, σ_h , of the hole volume as a function of temperature T for untreated (black), densified at 200 MPa (blue), and CO₂ gas-exposed and degassed (red) COC and PC.

Mesopores - Controlled pore glasses



Controlled pore glasses - CPG



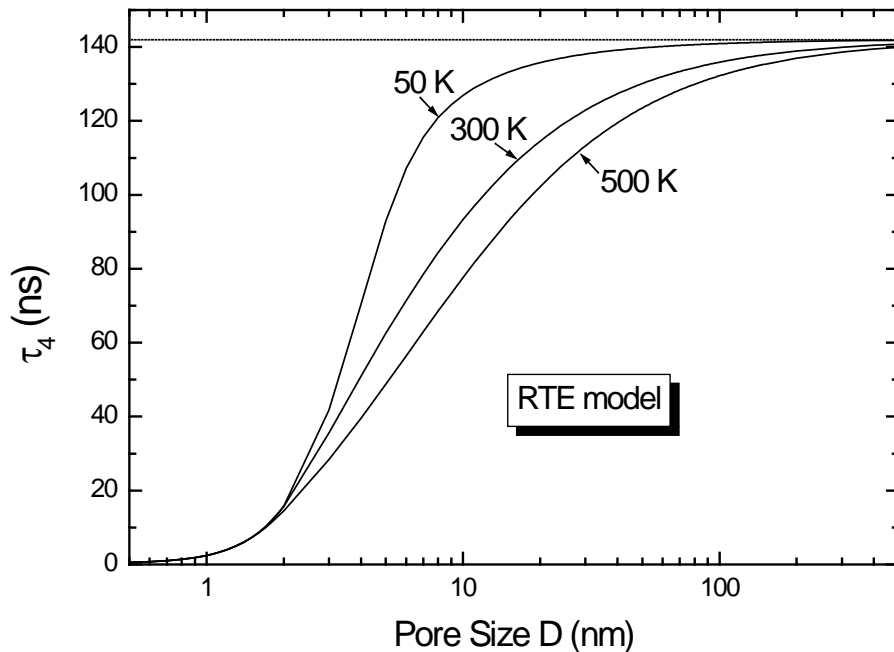
d_p 1 to 110 nm

- spinodal phase separation
- decomposition is initiated by heat treatment
- alkali rich borate phase \leftrightarrow pure silica
- alkali phase soluble in acid \rightarrow silica network
- pore size depends on basic material
- shape depends on duration and T of heat treatment

Model for $R > 1$ nm - RTE

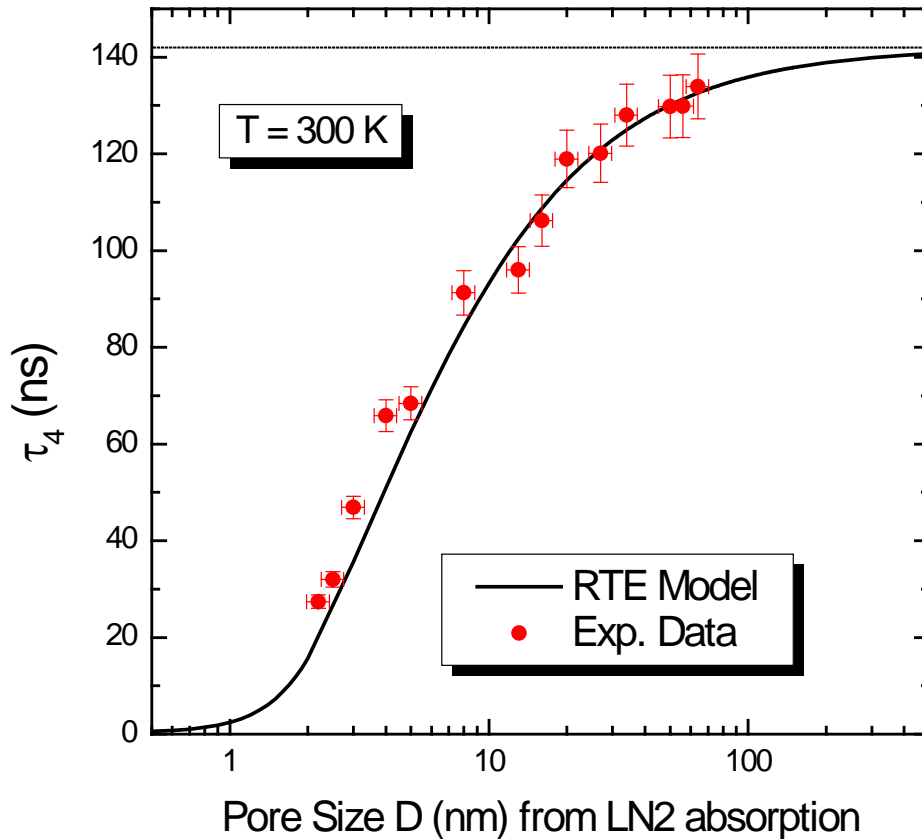
- Rectangular TE model = RTE model (for 3D cubic pores):

$$\lambda_{RTE}(D, T) = \lambda_A - \frac{\lambda_S - \lambda_{3\gamma}}{4} \left[1 - \frac{2\delta}{D} + \frac{\sum_{i=1}^{\infty} \frac{1}{i\pi} \sin\left(\frac{2i\pi\delta}{D}\right) e^{\left(\frac{-\beta i^2}{D^2 kT}\right)}}{\sum_{i=1}^{\infty} e^{\left(\frac{-\beta i^2}{D^2 kT}\right)}} \right]^3$$



- Boltzmann statistics ascribes explicit temperature dependence to the lifetime
- Rectangular geometry -> prevention of complicated Bessel functions
- $\delta = 0.18$ nm analogous to TE model

The experiments at room temperature



- we measured porous glass in a broad pore size range
- pore size obtained by N_2 -adsorption method
- for $T=300 \text{ K}$ general agreement to the RTE model
- calibration curve for the correlation of o-Pos lifetime and pore size

The RTE model

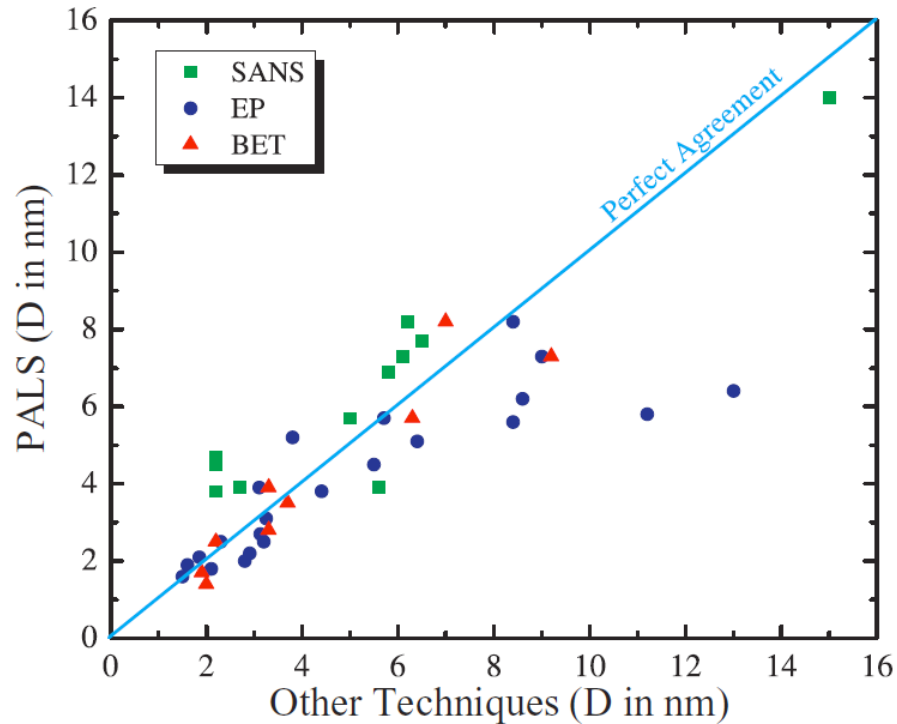


Figure 5 (Top) Pore size calibration calculated at different temperatures versus mean-free path. (Bottom) Recent round-robin comparisons of PALS pore diameters with those measured by small-angle neutron scattering (SANS), ellipso-metric porosimetry (EP), and gas absorption (BET).

Small pores in the wall of larger pores

Microporous and Mesoporous Materials 182 (2013) 136–146

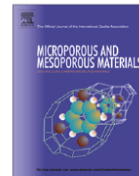


ELSEVIER

Contents lists available at [ScienceDirect](http://www.sciencedirect.com)

Microporous and Mesoporous Materials

journal homepage: www.elsevier.com/locate/micromeso



Transformation of porous glasses into MCM-41 containing geometric bodies

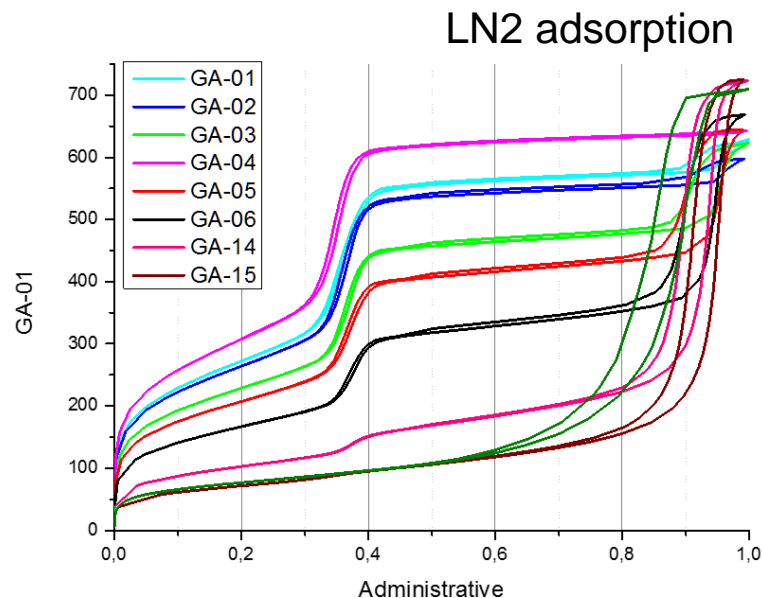


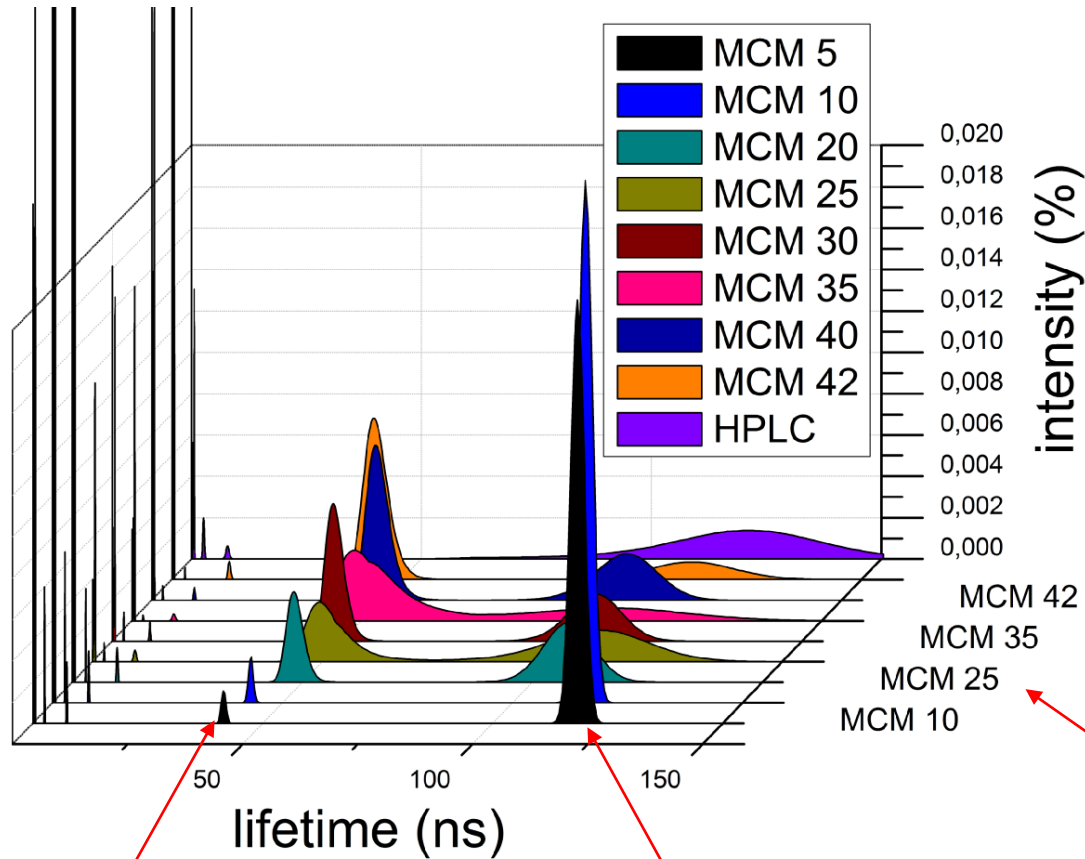
Hans Uhlig^{a,*}, Marie-Luise Gimpel^a, Alexandra Inayat^b, Roger Gläser^a, Wilhelm Schwieger^b, Wolf-Dietrich Einicke^a, Dirk Enke^a

^a University of Leipzig, Institute of Chemical Technology, Linnéstr. 3, 04103 Leipzig, Germany

^b University of Erlangen-Nuremberg, Institute of Chemical Reaction Engineering, Egerlandstr. 3, 91058 Erlangen, Germany

Sample	Amount of tenside solution in ml	new sample name
GA-01	40	MCM-40
GA-02	35	MCM-35
GA-03	30	MCM-30
GA-04	42	MCM-42
GA-05	25	MCM-25
GA-06	20	MCM-20
GA-14	10	MCM-10
GA-15	5	MCM-05





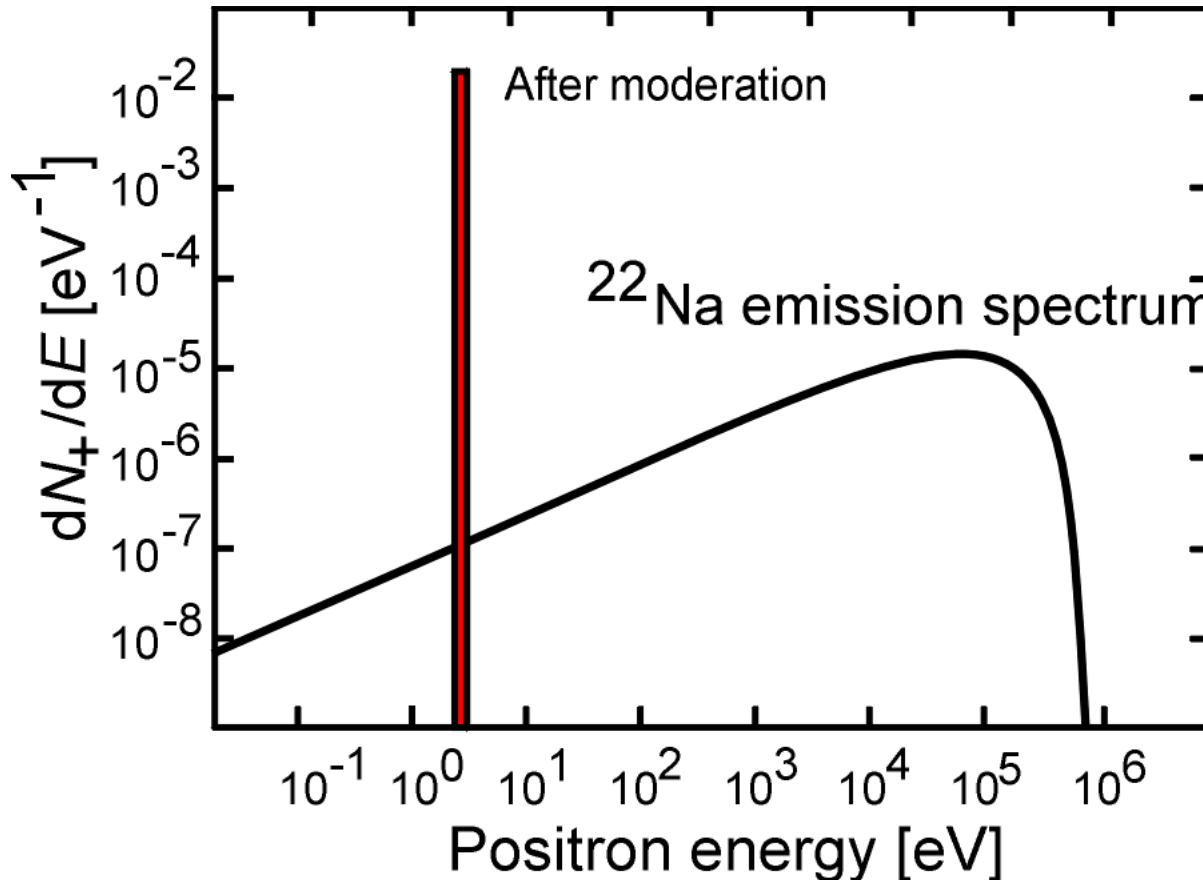
- solvent (MCM) was added into a larger pore system
- large pores: 15 nm
- small pores are formed in the walls: 4 nm

amount of solvent

4 nm pores

15 nm pores

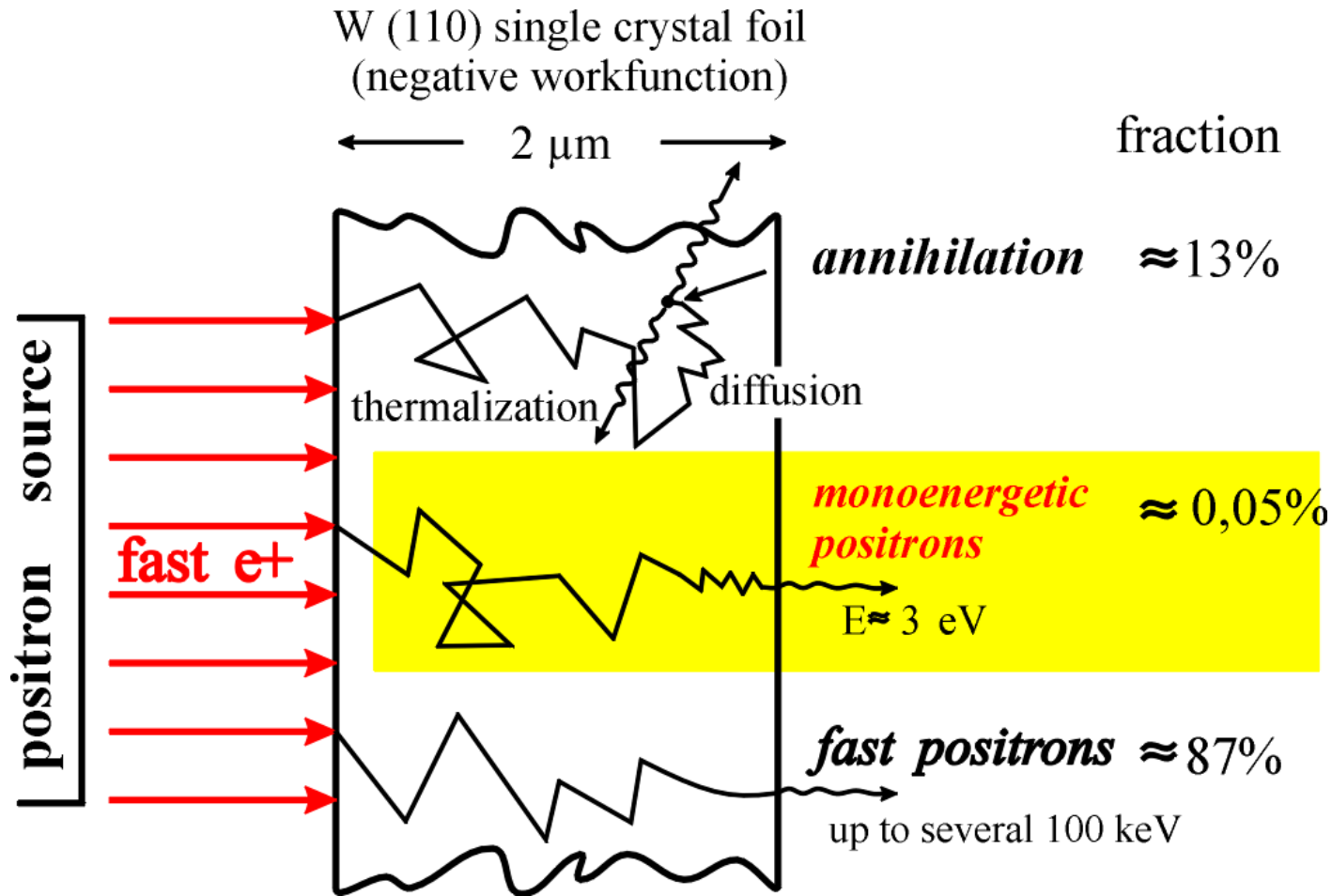
The Slow-Positron Beam Technique



- broad positron emission spectrum from beta sources
- deep implantation into solids
- no use for study of defects in thin layers
- moderation necessary

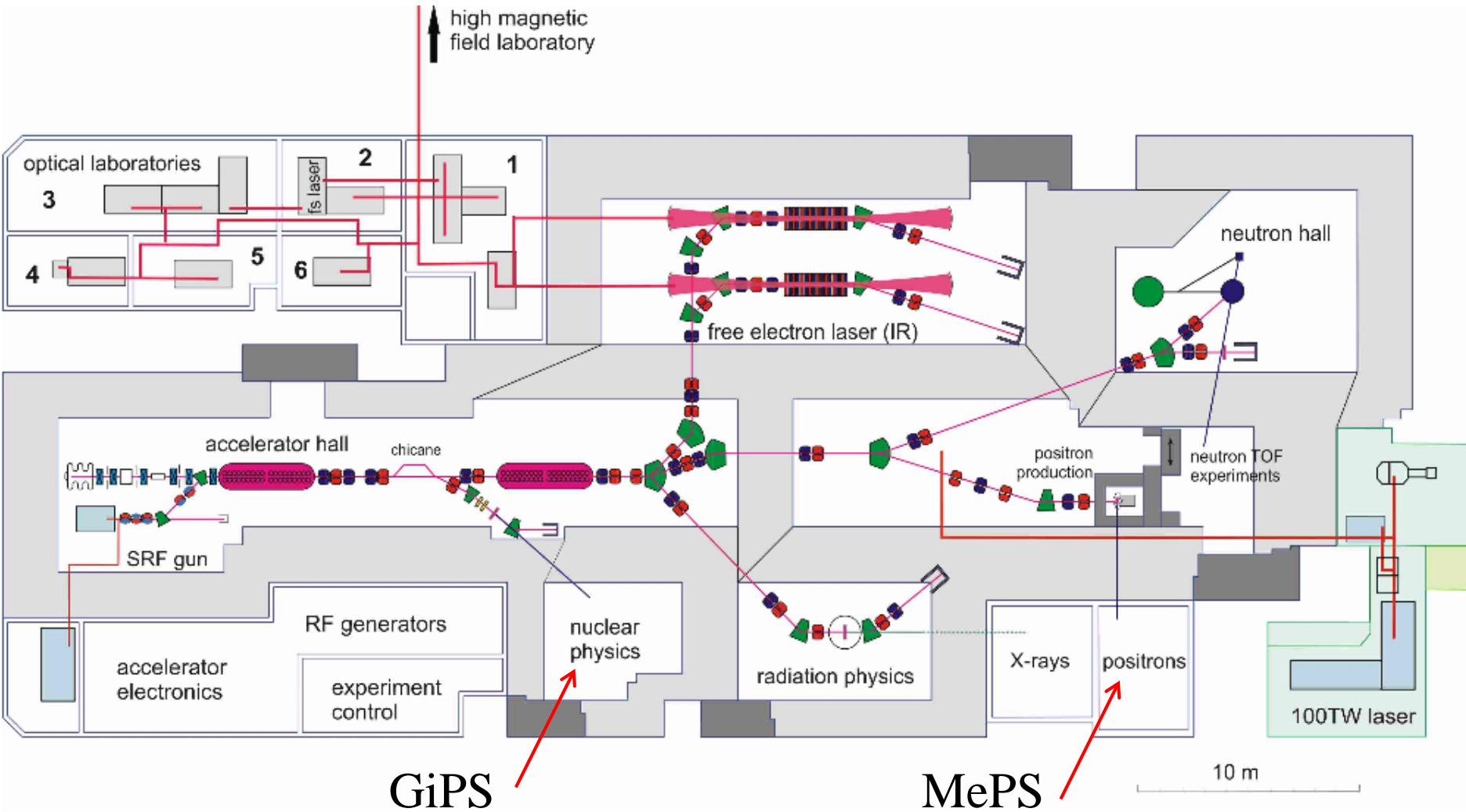
Mean implantation depth of un-moderated positrons ($1/e$): Si: $50\mu\text{m}$

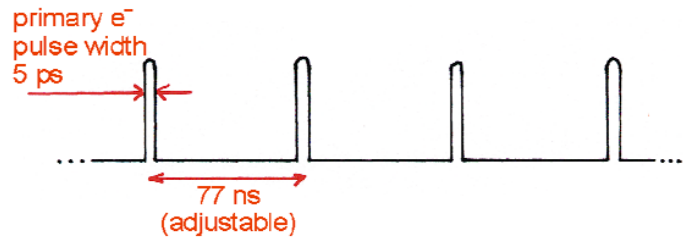
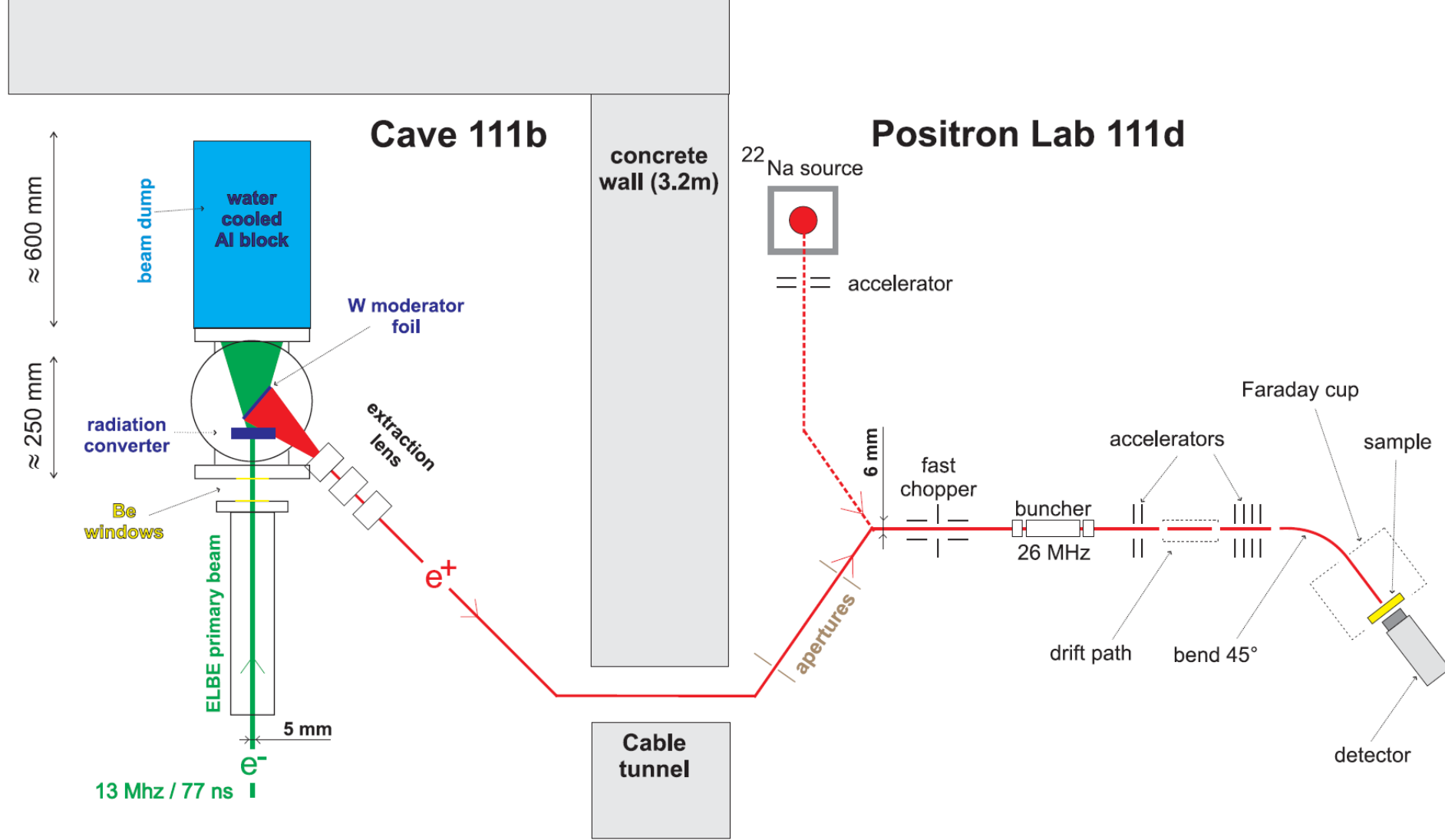
Moderation of Positrons



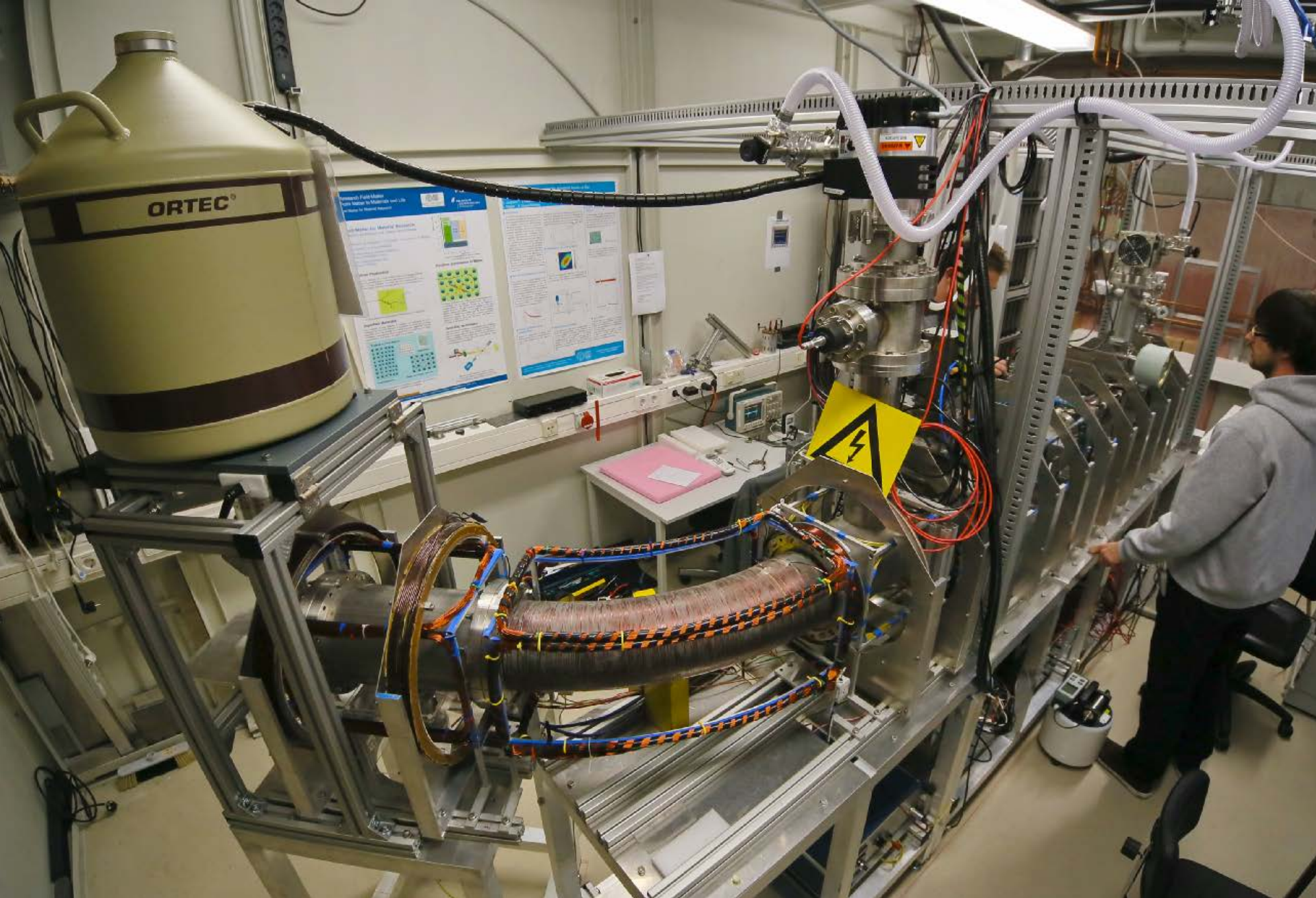
moderation efficiency: $\approx 10^{-4}$

HZDR Dresden-Rossendorf: Ground map of the ELBE hall





MePS scheme



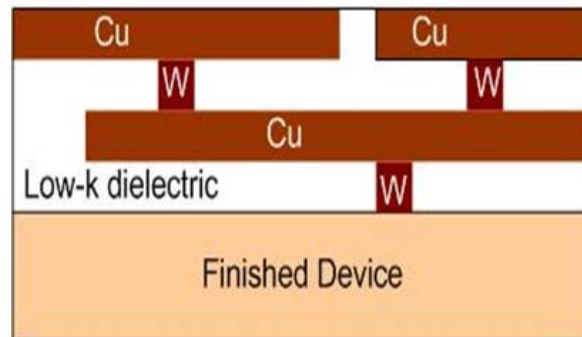
MePS system @ ELBE, 26. November 2013

Low-K dielectric layers

- modern ultra-large scale microprocessors suffers from long relaxation times
- information transport is limited by product $R \times C$
- R has been decreased: Copper technology (instead of Al)
- C is relatively high when SiO_2 is used as isolation layer; $\epsilon_r=4$

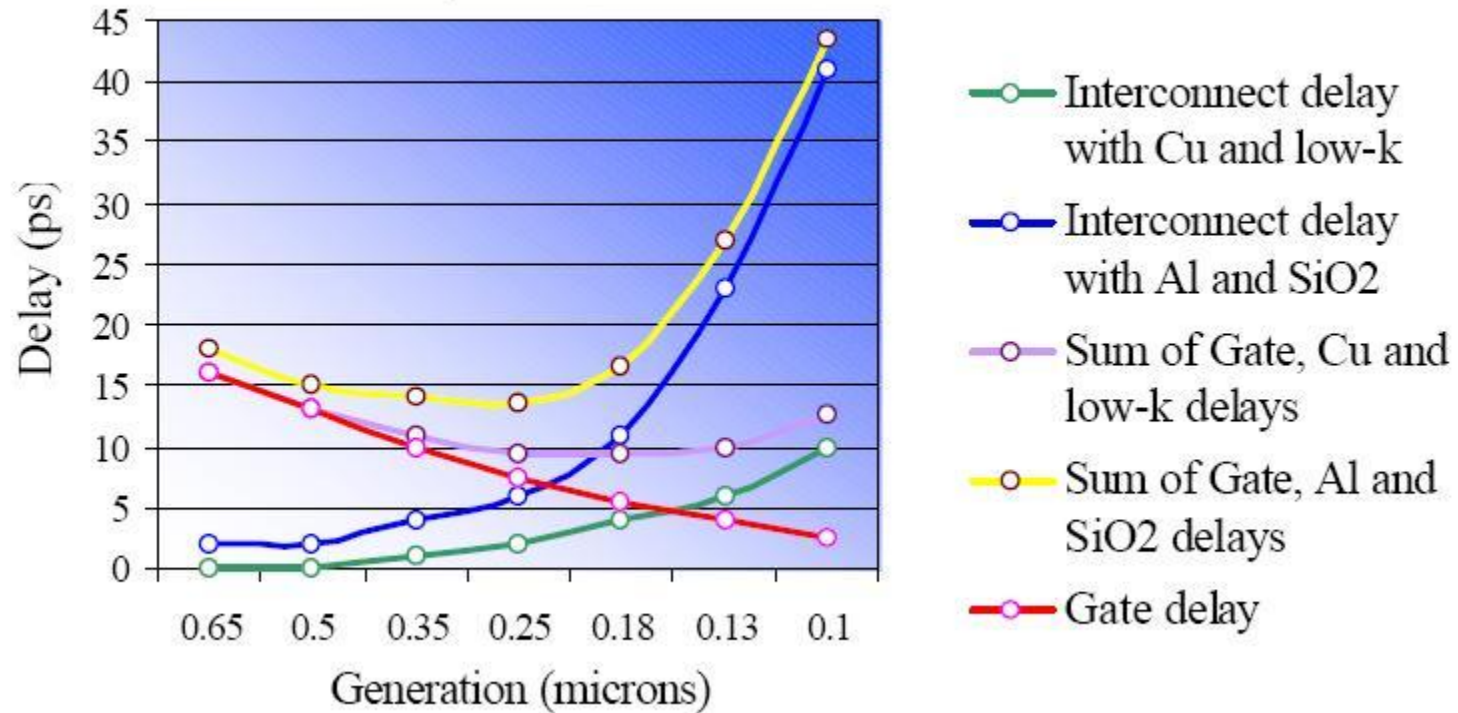
$$C = \frac{\epsilon_0 \epsilon_r A}{d}$$

- low-k (small $\epsilon_r = 2 \dots 2.5$) layers may help
- these are layers with micropores with pore size of $d \approx 1$ nm with high porosity
- problem for characterization: closed porosity

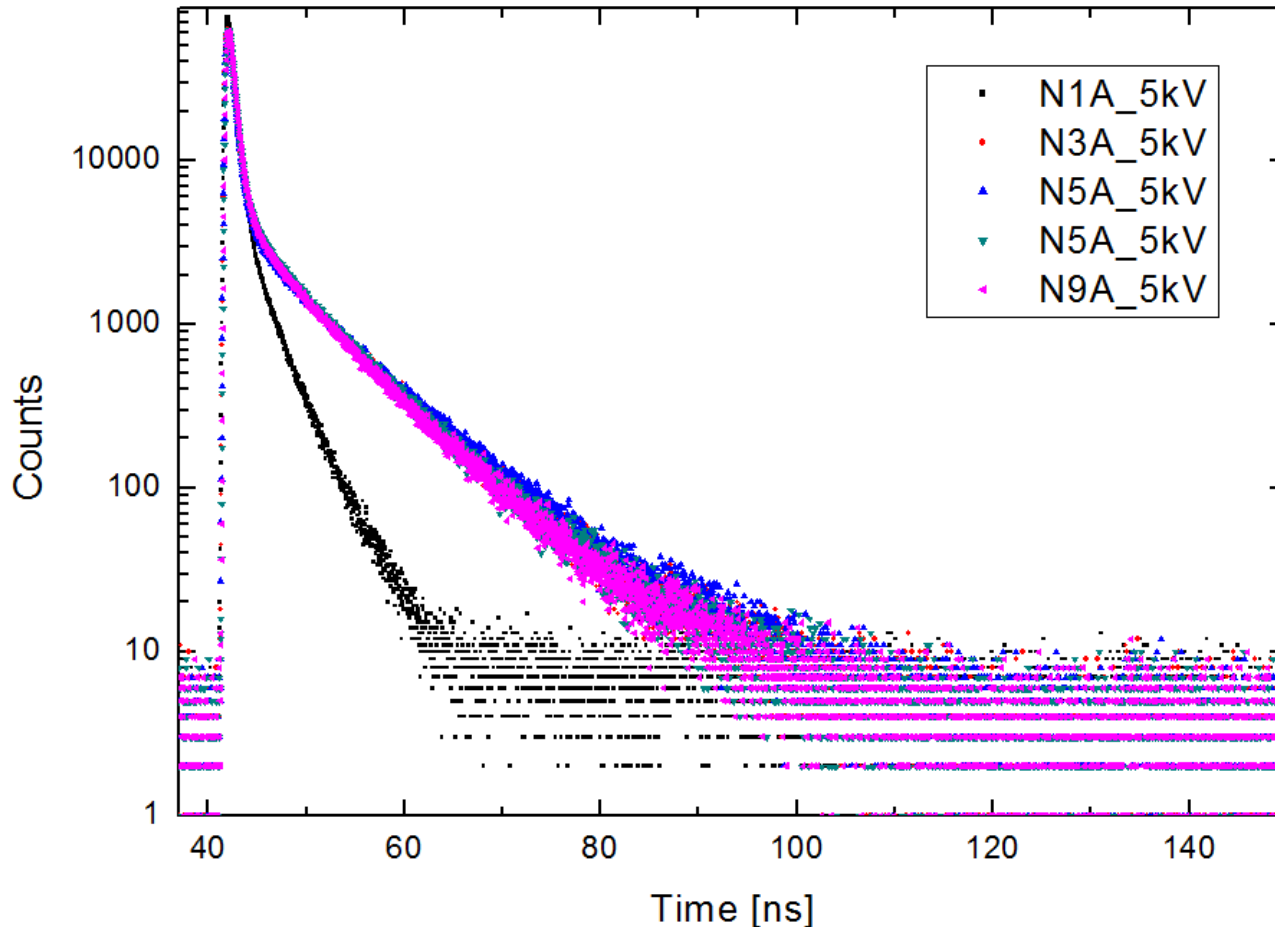


Low-K dielectric layers

Delay as Function of Feature Size

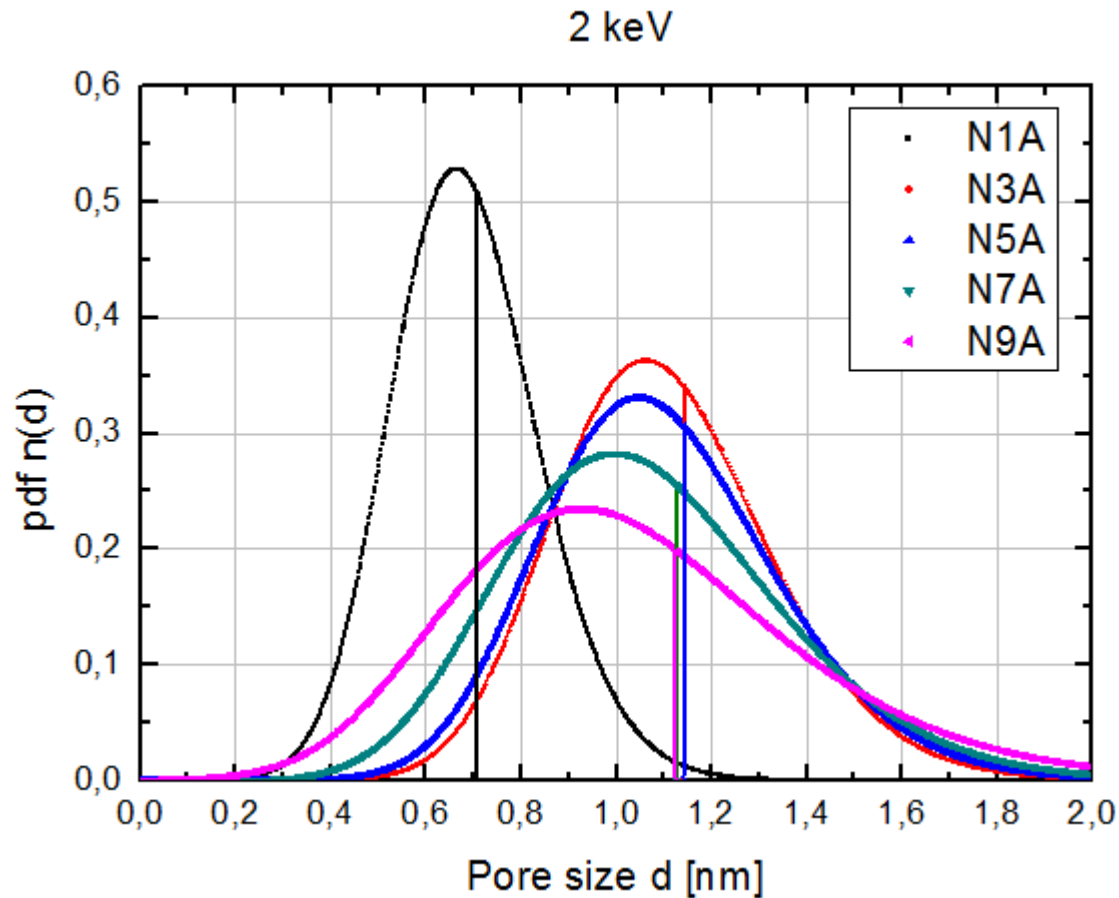


Low-K dielectric layers



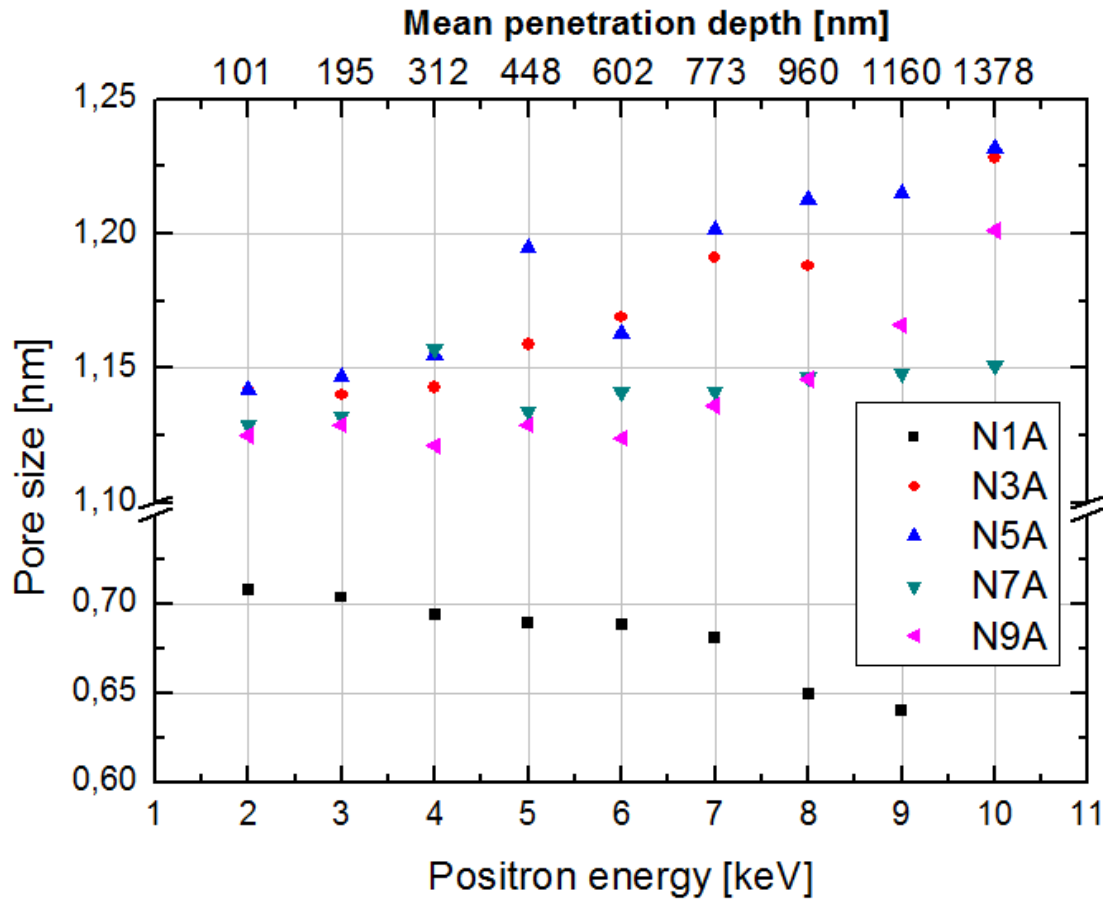
- Positrons are ideal tool for closed porosity in low-k layers
- Lifetime spectra of differently treated low-K layers
- Treatment:
 - untreated porous layer
 - plasma treatment for compaction
 - TiN cap layer

Low-K dielectric layers



- dispersion of lifetime gives the size distribution of the pore system

Low-K dielectric layers



- monoenergetic positrons can be used to depth scan the layer
- monoenergetic positrons are obtained by moderation

Summary

- PALS is a useful porosimetry tool
 - very sensitive method for **small pores (0.3 to 10 nm)**
 - upper sensitive limit ≈ 60 nm
 - **non-destructive** method
 - Works in open and **closed pore** systems
 - applicable also for **thin layers (50 ... 2000 nm)**
-

HZDR Dresden-Rossendorf 21.-23. October 2015

Workshop

Methods of Porosimetry and Applications

The workshop will treat aspects of the different methods of porosimetry, such as N₂-Adsorption, Hg intrusion, SAXS, SANS and Positron Annihilation. Tutorial talks will be given about these topics. The limitations and possible applications of these techniques will be discussed. The workshop will be organized at the Institute of Radiation Physics at HZDR in Dresden-Rossendorf.

Dr. A. Wagner

Prof. D. Enke

Prof. R. Krause-Rehberg



**Helmholtz-Zentrum
Dresden-Rossendorf**



**Martin-Luther-Universität
Halle-Wittenberg**

*“A theory is something nobody believes,
except the person who made it.
An experiment is something everybody
believes, except the person who made it.”*

Albert Einstein (American German 1879-1955)

Acknowledgement

Uni Halle

Stefan Thränert
Dirk Enke
Marco Jungmann
Maik Butterling
Steve Zieger
Thomas Cudrig
Mohamed Elsayed

HZDR

Andreas Wagner
Maik Butterling
Wolfgang Anwand
....and more

